

P7-12

# Development of Heat Flow Measurement Using Thermal Probe Method in Divertor Simulator MAP-II

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# Abstract

We are improving the measurement method of the heat flow ( $Q$ )– the sheath potential ( $V$ ) characteristic for the thermal probe method.

## The method of biasing the thermal probe

Time constant to achieve the steady state is  $123 \pm 18$  sec.

The following measurement method is applicable.

1. change the bias in a stepwise manner
2. deduce the temperature at the steady state by a functional fit of the temperature variation.

## Q-V curve and the analysis for $T_i$ and $R_E$

$Q_{exp}$  from the temperature gradient has the  $V$ -dependent difference ( $Q_{dif}$ ) compared to  $Q_{cal}$  from the calculation using the sheath theory.

The  $V$  dependence of  $Q_{dif}$  enables us to analyze  $T_i$  and  $R_E$ .

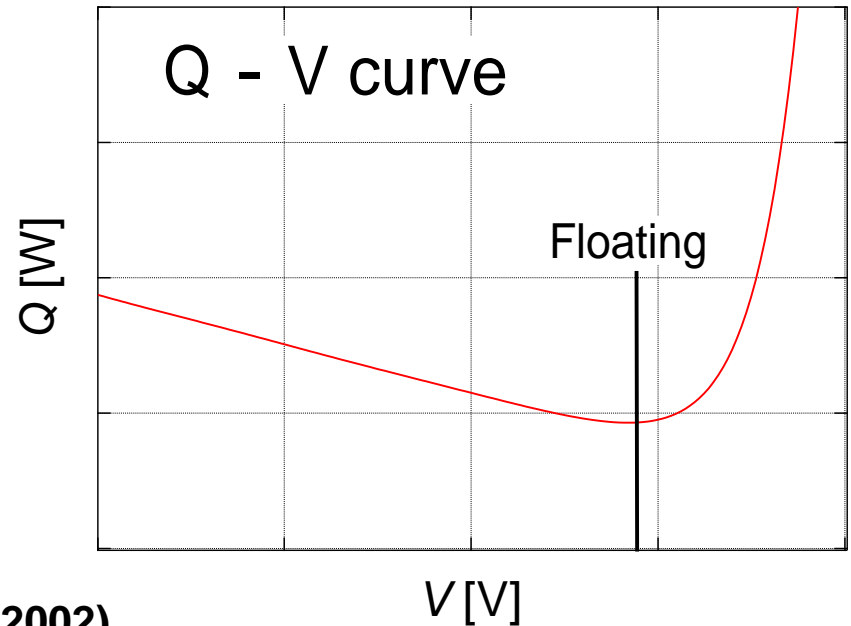
➔ The error of  $T_i$  is large caused by the error in  $Q_{exp}$ .

Reliable in-situ calibration of the heat flow is required.

# Background

The thermal probe method uses **the heat flow ( $Q$ ) – the sheath potential ( $V$ ) characteristic** in order to deduce the various plasma parameters.

- **negative ion density** [1]
- **ion temperature** [2,3]



[1] E. Stamate *et al.*, Appl. Phys. Lett. 80, 3066 (2002).

[2] H. Matsuura and K. Michimoto, Contrib. Plasma Phys. 44, 677 (2004).

[3] K. Kurihara and S. Kado *et al.*, Trans. Fusion Sci. Tech. (2007) *in press*

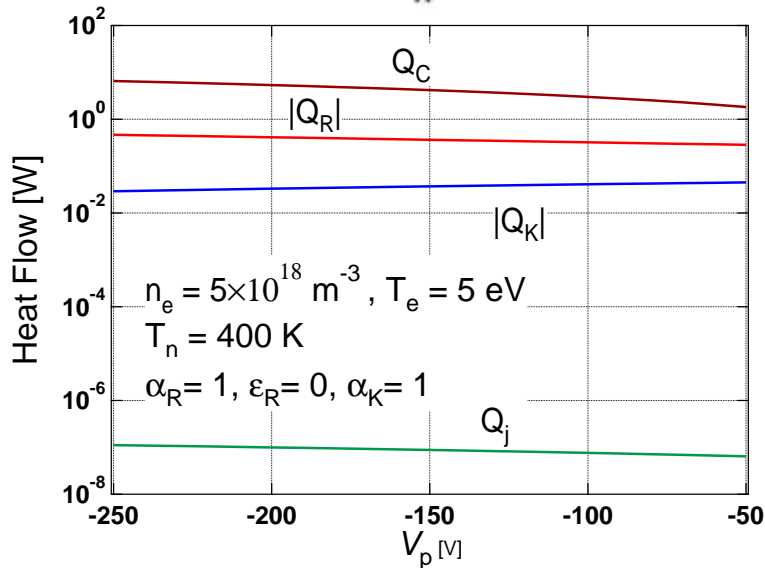
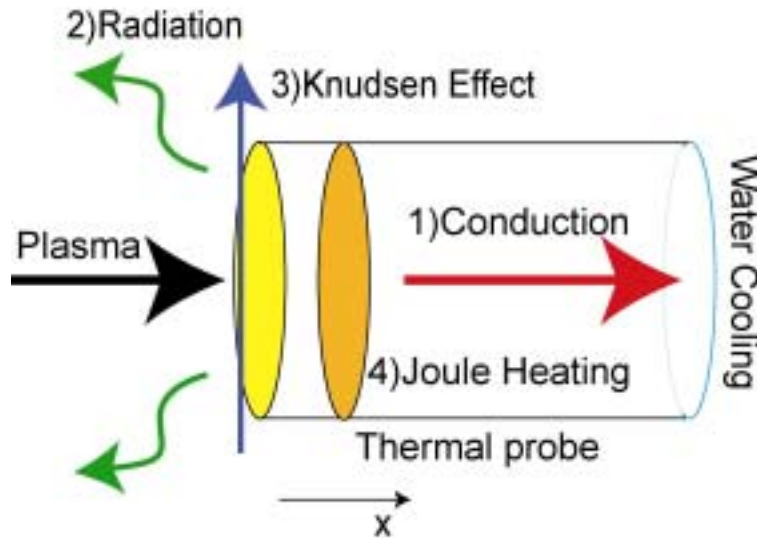
The time resolution of the thermal probe method is poor in nature because of the long transient time in thermal phenomena.

**It is necessary to improve the time response of the thermal probe.**

- The measurement of the time constant to achieve the steady state
- The improvement in the  $Q$ - $V$  characteristic measurement methods

# Heat transfer in thermal probe

## Heat transfer in the thermal probe



### 1) Heat Conduction

$$Q_C = -S \kappa \left. \frac{dT_p}{dx} \right|_{x=Surface}$$

$\kappa$ : thermal conductivity

### 2) Heat Radiation

$$Q_R = S \sigma (\epsilon_R T_p^4 - \alpha_R T_n^4)$$

$\epsilon_R$ : emissivity     $\alpha_R$ : absorptivity

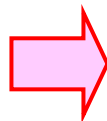
### 3) Knudsen Effect

$$Q_K = S p \frac{1}{4} \frac{\gamma + 1}{4(\gamma - 1)} \sqrt{\frac{8kT_n}{\pi m_i}} \alpha_K \left| \frac{T_p}{T_n} - 1 \right|$$

$\alpha_K$ : Accommodation coefficient

### 4) Joule heating

$$Q_j = \rho \frac{L}{S} I_p^2$$



**Heat conduction is dominant.**

# Temperature variation

1-dimensional heat equation

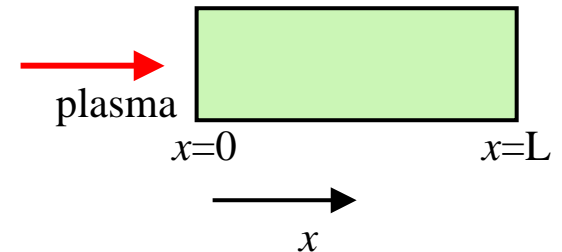
$$\frac{\partial T}{\partial t} = \alpha \frac{\partial^2 T}{\partial x^2}$$

$\alpha$ : the thermal diffusivity

under the boundary condition

$$\left. \frac{\partial T}{\partial x} \right|_{x=0} = \text{const.}$$

$$\left. \frac{\partial T}{\partial t} \right|_{x=L} = 0$$



Considering the sign of  $\partial T / \partial t$  doesn't change with any  $x$

$$T(x_1, t) = T(x_1, \infty) + \{ T(x_1, 0) - T(x_1, \infty) \} \exp\left(-\frac{t}{\tau}\right)$$

where

$x_1$ : one point in the thermal probe,  $\tau$ : the time constant to archive the steady state

$$\tau = \frac{1}{\alpha} \frac{4L^2}{\pi^2}$$

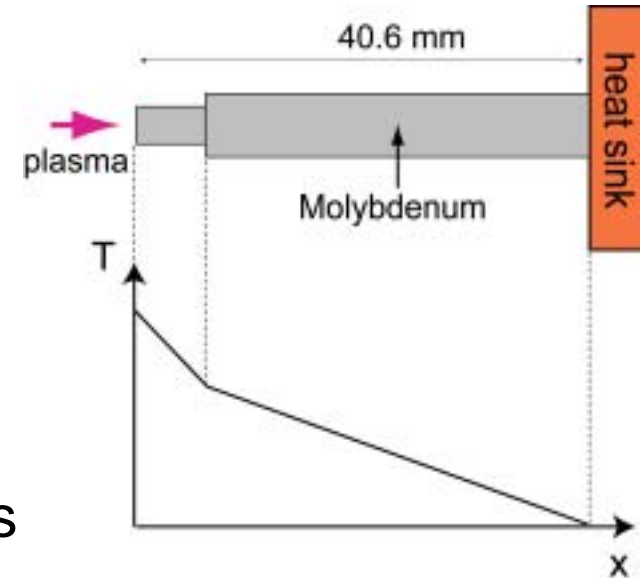
( $\tau$  depends only on the probe length for a given material)

# Q- V characteristic

Since the heat conduction is dominant in the thermal probe,  $Q(V)$  can be written as

$$Q(V) = -\kappa \frac{\Delta T(x, \infty, V)}{\Delta x} S$$

From the sheath theory [1],  $Q$  can be written as



$$Q(V) = \underbrace{I_{is}(V)}_{\text{Ion current}} \times \left[ \underbrace{\{2T_i - V\}}_{\text{Thermal motion}} \underbrace{(1 - R_E)}_{\text{Acceleration by sheath}} + \underbrace{E_{rec}}_{\text{recombination}} \right] + \underbrace{\{I_p(V) - I_{is}(V)\}}_{\text{Electron current}} \times 2T_e$$

Ion current

Thermal motion

Acceleration by sheath

recombination

Electron current

$I_{is}$ : ion saturation current (measurement value)

$I_p$ : Probe current (Electron current + Ion current)

$V$ : Sheath potential

$R_E$ : energy reflection coefficient (ALADDIN database [2])

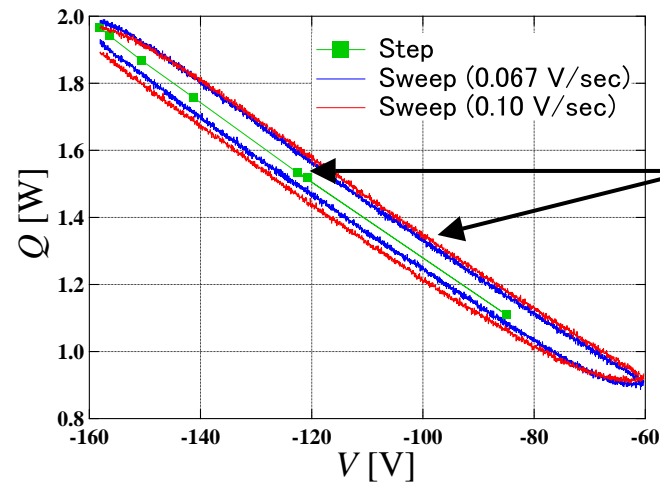
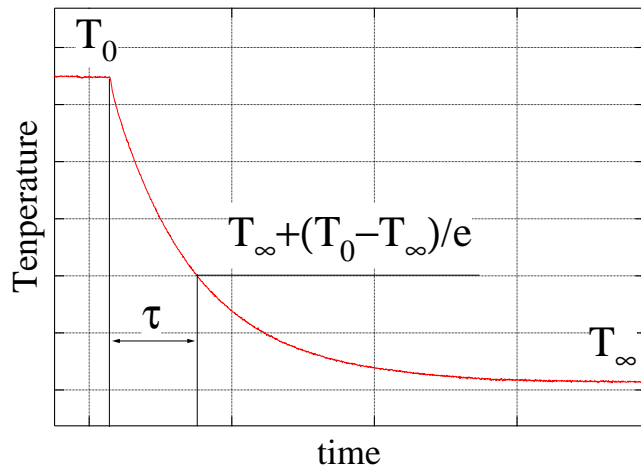
$E_{rec}$ : recombination energy (constant)

[1] P.C. Stangeby *Physics of plasma-Wall Interactions in Controlled Fusion*, eds. D.E. Post and R. Behrisch (Plenum Press, New York, 1984) p. 41.

[2] IAEA AMDIS ALADDIN database  
<http://www-amdis.iaea.org/ALADDIN/>


# Q-V characteristic measurement

## Two methods for the Q-V characteristic measurement




The results of the method 2 don't agree with those of the method 1.

### 1. Changing the bias in a stepwise manner: $T(x, \tau)$ is obtained by fitting.

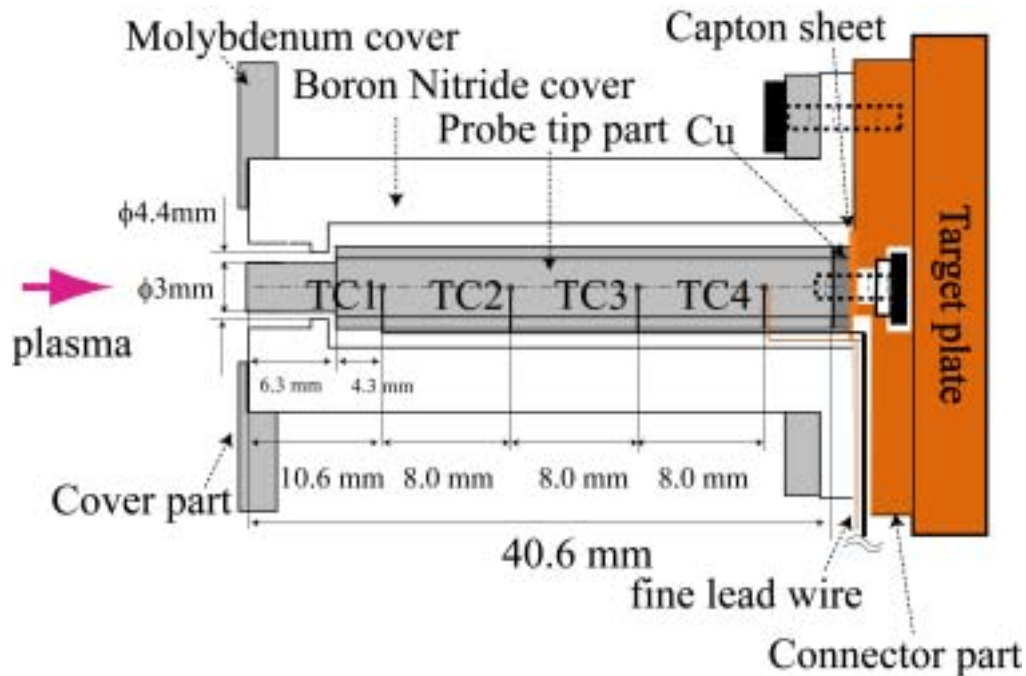
- The temperature at the transient state is measured.  This improve the time response
- Only finite data points can be obtained.

### 2. Sweeping the bias continuously: $T(x, \tau)$ is directly measured.

- Continuous Q-V curve can be obtained. (reliable analysis)
- If the sweeping speed is fast against the heat transfer phenomena, the temperature at the steady state is not measured.

 The method 1 is more applicable than the method 2 under the long time constant ( $\sim 125$  s under our condition).

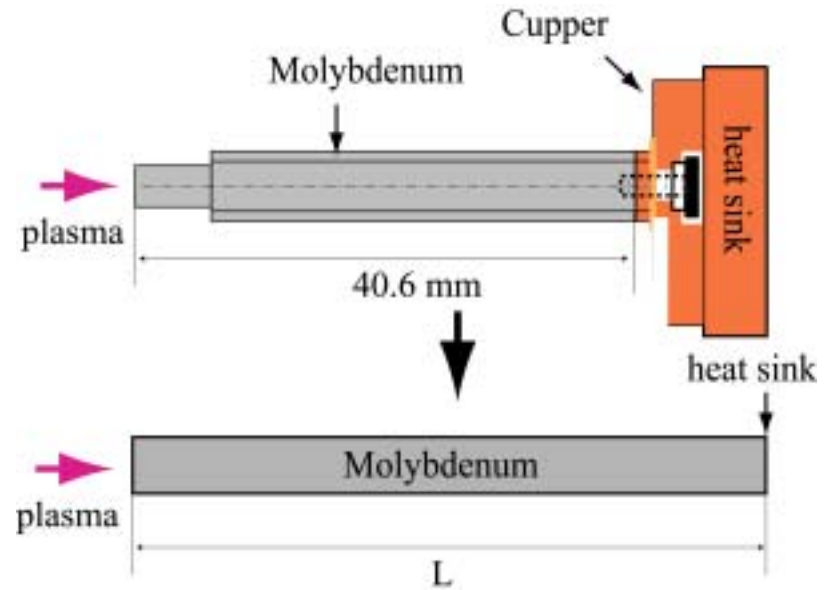
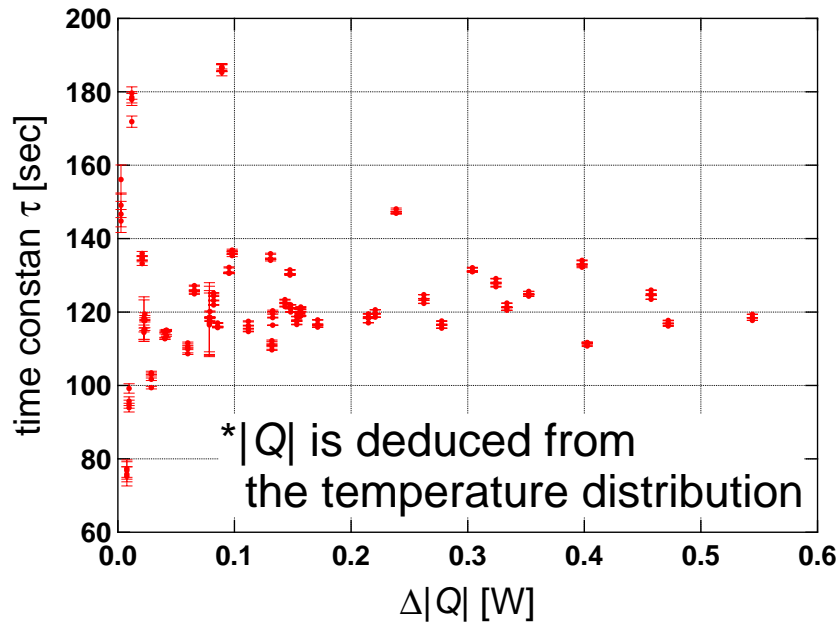
# Apparatus - thermal probe -



- The probe tip is made of **Mo** (**3 mm $\phi$**  (Left part), **5 mm $\phi$**  (Right part), **40.6 mmL**).
- The thermal probe is equipped with four K type thermo-couples for the **temperature gradient measurement** and with a fine lead wire for **biasing the thermal probe as well as the probe current measurement**.
- The  **$Q-V$  characteristic and  $I-V$  characteristic can be obtained simultaneously**.
- The probe tip is insulated from both Mo cap and Cu heat sink using an boron nitride cover and double capton sheets, respectively.
- Cu target plate is cooled by an incubator and two external coolant tubes.



# Time constant and Virtual probe 1



**The time constant is independent of  $\Delta|Q|$ .  $\tau$  is  $123 \pm 18$  sec.**

**The deviation of  $\tau$  becomes small for  $\Delta|Q| > 0.1$  W**

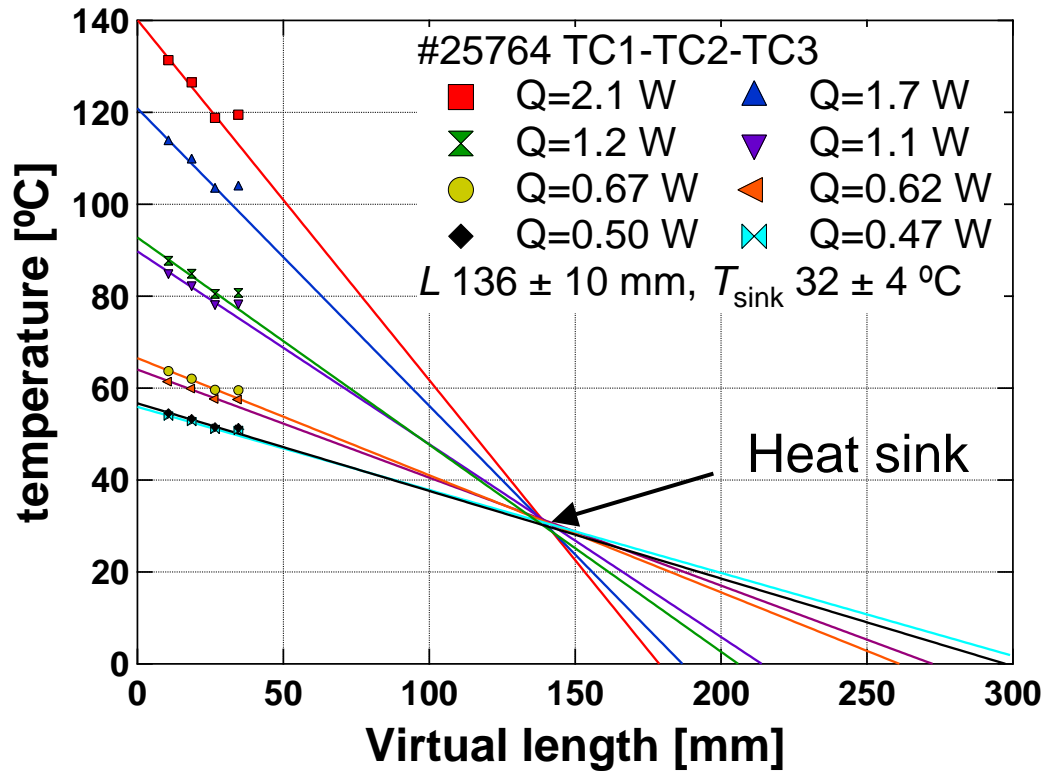
The length of the real probe is 40.6 mm (Mo part).

If the right edge is heat sink,  $\tau = 12$  sec from  $\tau [s] = 7.55 \times 10^9 L^2 [\text{mm}]$

**The practical probe length should be interpreted as that of an equivalent probe made of the uniform material**

The length of the virtual probe  $L = 128 \pm 49$  mm from  $L [\text{mm}] = 1.15 \times 10 \sqrt{\tau}$

# Virtual probe 2



\*Thermo-couple = TC

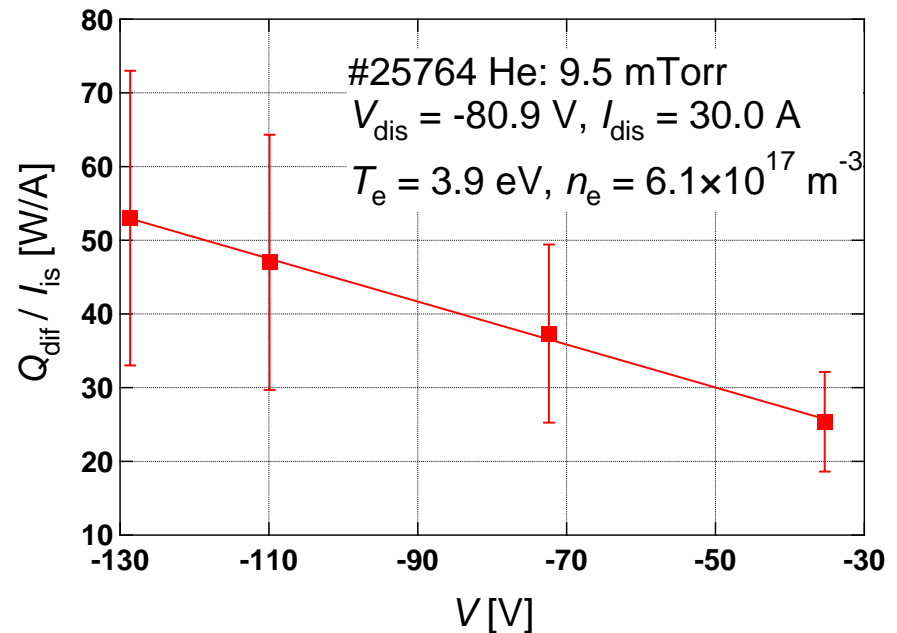
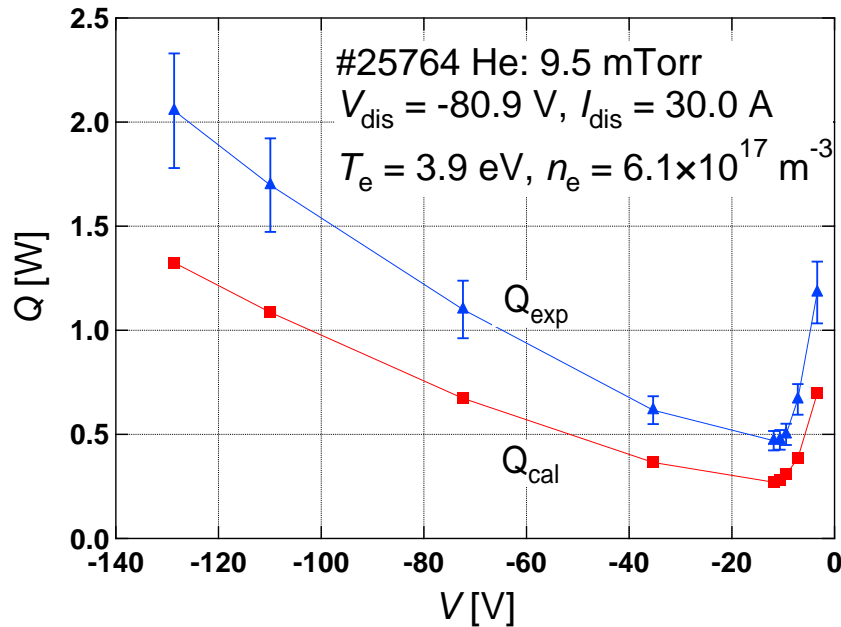
**$L$  from the TC set except TC4 has good agreement with that from  $\tau$ .**

**We choose the set of TC1-TC2-TC3 because the value deduced from 3TCs is more reliable than that from 2 TCs.**

TC set	$L$ [mm]	$T_{\text{sink}}$ [ $^\circ\text{C}$ ]
12	$177 \pm 14$	$30 \pm 5$
13	$135 \pm 10$	$32 \pm 4$
14	$218 \pm 14$	$28 \pm 4$
23	$114 \pm 7$	$33 \pm 4$
24	$245 \pm 12$	$26 \pm 3$
123	$136 \pm 10$	$32 \pm 4$
124	$221 \pm 14$	$28 \pm 4$
1234	$196 \pm 13$	$29 \pm 4$
$\tau$	$123 \pm 18$	

\*The errors are deduced from the means of all cross point, not including the error of the cross point.

# Q-V characteristic and $T_i$



$Q_{\text{exp}}$ : heat flow deduced from the temperature gradient in the thermal probe  
 Temperature distribution of TC1-TC2-TC3 is adopted.

$Q_{\text{cal}}$ : heat flow deduced from the sheath theory using experimental data of  $I_p$ .  
 $I_p$ : measured by thermal probe,  $R_E$ : interpolated from the database,  $T_i$ : assuming  $T_i = 0$ .

Between  $Q_{\text{exp}}$  and  $Q_{\text{cal}}$ , there is the V-dependent difference  $Q_{\text{dif}}$ .



$Q_{\text{dif}} / I_{\text{is}}$  has the linear dependence on V.

\*The process of  $Q_{\text{dif}}$  is now under investigation.

$T_i$  and  $R_E$  can be deduced assuming this dependence.

# The procedures to deduce $T_i$ and $R_E$

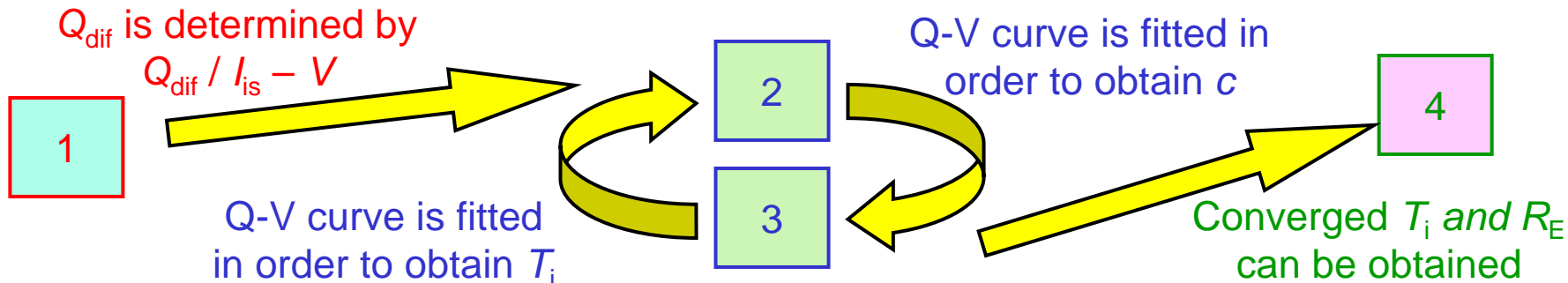
1. Assuming  $Q_{dif} / I_{is}$  is linear to  $V$  in the ion dominant region, the slope  $a$  and intercept  $b$  ( $Q_{dif} / I_{is} = a \times V + b$ ) can be deduced from  $Q_{dif} / I_{is} - V$ .

Adding to the contribution of  $Q_{dif}$ , we have

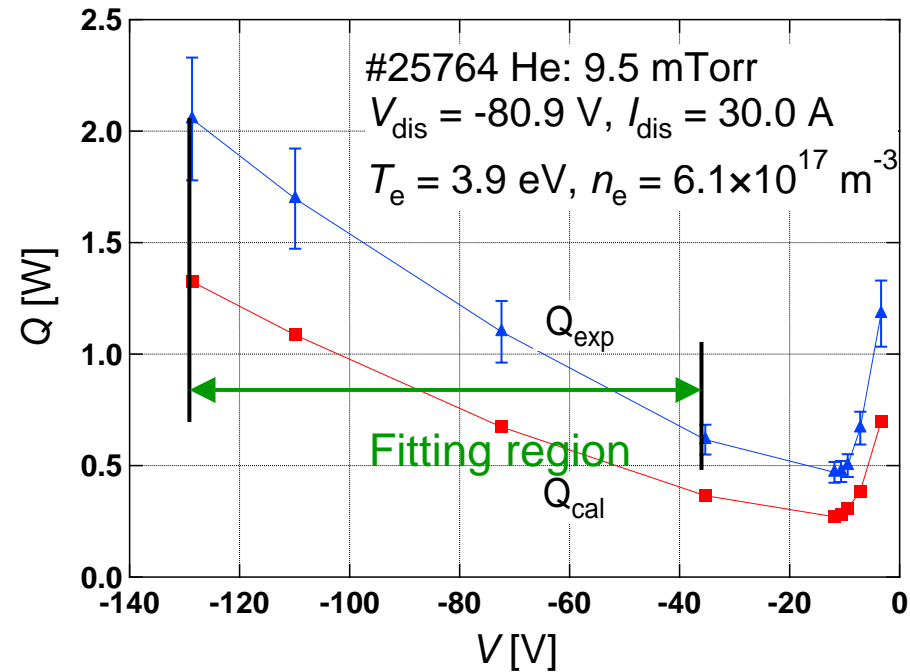
$$\begin{aligned} Q_{exp} &= I \left\{ (2T_i - V)(1 - R_E) + E_{rec} \right\} + Q_{dif} \\ &= I \left\{ (2T_i - V)(1 - cR_E) + E_{rec} + aV + b \right\} \end{aligned}$$

\* $c$  is the calibration factor for  $R_E$ , introduced to make use of the  $V$  dependence of  $R_E$ .

2.  $Q-V$  curve is fitted to the equation in order to obtain  $c$  ( $T_i$  is fixed).
3.  $Q-V$  curve is fitted again in order to obtain  $T_i$  using  $c$  obtained in 2.
4. The procedures of 3 and 4 are repeated until  $T_i$  and  $c$  converge.



# Error estimation of $T_i$



$T_i$  and  $c$  obtained from the analysis in the fitting region.

$$T_i = 0.17 \pm 41.6 \text{ eV}$$

$$c = 1.0 \pm 0.8$$

The error of  $T_i$  and  $c$  is too large.

This is because the large error in  $Q_{\text{exp}}$  influences those in  $a$ ,  $b$ ,  $c$  and  $T_i$ .

Without the error in  $I_{\text{is}}$  and  $V$ ,  $\delta T_i$  is written as

$$\delta T_i = \sqrt{\left(\frac{\partial T_i}{\partial Q_{\text{exp}}} \delta Q_{\text{exp}}\right)^2 + \left(\frac{\partial T_i}{\partial a} \delta a\right)^2 + \left(\frac{\partial T_i}{\partial b} \delta b\right)^2 + \left(\frac{\partial T_i}{\partial c} \delta c\right)^2}$$

	<b>13 eV</b>	<b>13 eV</b>	<b>19 eV</b>	<b>31 eV</b>	$\delta T_i = 41.6 \text{ eV}$
1/10 of $\delta Q_{\text{exp}}$	<b>1.3 eV</b>	<b>1.6 eV</b>	<b>2.3 eV</b>	<b>3.6 eV</b>	$\delta T_i = 4.8 \text{ eV}$

We have to improve the accuracy of the  $Q_{\text{exp}}$  for the reliable  $T_i$ .

# Conclusion

We are improving the measurement method of the  $Q$ - $V$  characteristic for the thermal probe method.

1) The time constant  $\tau$  and the method of biasing the thermal probe

$\tau = 123 \pm 18$  s, and was independent of the  $\Delta|Q|$ .

➔ The stepping method is more applicable than the sweeping method.

2)  $Q$ - $V$  curve and the analysis for  $T_i$

$Q_{\text{exp}}$  has the difference  $Q_{\text{dif}}$  compared to  $Q_{\text{cal}}$ . The process of  $Q_{\text{dif}}$  is under investigation.

$T_i$  and  $R_E$  can be analyzed by using the linear  $V$  dependence of  $Q_{\text{dif}} / I_{\text{is}}$ .

But the errors of  $T_i$  and  $c$  are too big because of the error of  $Q_{\text{exp}}$ .

➔ We have to improve the accuracy of  $Q_{\text{exp}}$ .

## Future plan

- Reliable in-situ calibration of the heat flow
- Clarifying the process of the  $Q_{\text{dif}}$

\*This work was supported in part by a NIFS Collaborative Research Program (NIFS04KOAB009) directed by the second author.

# Appendix -differential equation-

Considering the sign of  $\partial T/\partial t$  doesn't change with any  $x$

$$\left. \frac{\partial T}{\partial t} \right|_{x=L} = 0 \quad \longrightarrow \quad \cos(\lambda L) = 0$$

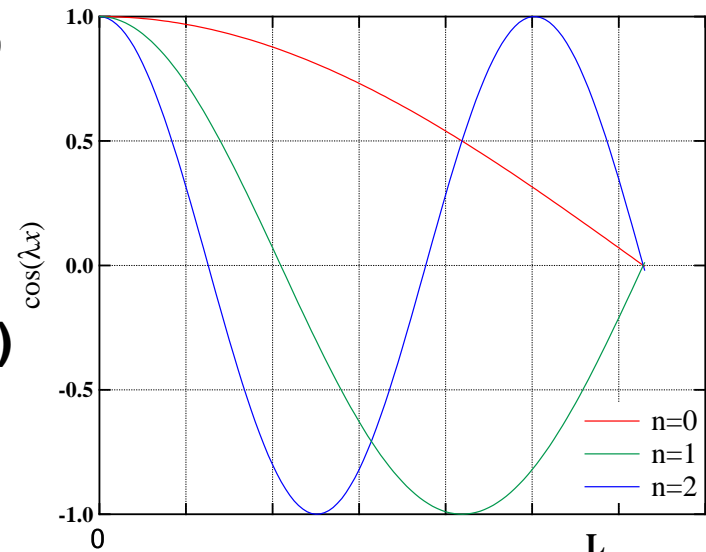
$$\longrightarrow \quad \lambda L = \frac{\pi}{2} + n\pi \quad (n \in \mathbf{N})$$

The sign of  $\partial T/\partial t$  is determined by  $\cos(\lambda x)$

Considering the sign of  $\partial T/\partial t$   
doesn't change with any  $x$

(The temperature always varies toward the  $T(x, \quad)$ )

**Only  $n=0$  is satisfied with this condition.**



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